Docket No.

245557US0S X

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masanobu OGINO, et al.

SERIAL NO:

10/713.054

GAU:

2813

FILED:

November 17, 2003

EXAMINER: Thanh T. NGUYEN

RCE FILED: FOR:

August 25, 2006

SEMICONDUCTOR SUBSTRATE AND METHOD OF MANUFACTURE THEREOF

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

Applicant(s) wish to disclose the following information.

REFERENCES

- The applicant(s) wish to make of record the reference(s) cited in the attached Chinese Office Action (with English translation) and listed on the attached form PTO-1449. Copies of the listed reference(s) are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language reference(s).
- Online credit card payment is being made in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- Online credit card payment is being made in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Norman F. Oblon

Vincent K. Shier, Ph.D. Registration No. 50,552

Paul J. Killos Registration No. 58,014

Customer Number

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03)

Form PTO 1449 (Modified)		U.S. DEPARTMENT PATENT AND TRA	OF COMMERCE DEMARK OFFICE	ATTY DOCKET NO. 245557USOS X			SERIAL NO. 10/713,054		
				APPLICANT					
LIST OF	REFE	RENCES CITED BY AF	PPLICANT	Masanobu OGINO, et al.					
				FILING DATE			GROUP		
				November 17, 2003					
				RCE FILED			2813		
August 25, 2006									
U.S. PATENT DOCUMENTS									
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME CLASS			SUB FILING DATE CLASS IF APPROPRIATE		
	AA								
	AB								
	AC								
	AD								
	AE								
	AF								
	AG								
	АН								
	ΑI								
	AJ								
	AK		1						
	AL								
· · · · · · · · · · · · · · · · · · ·	AM								
	AN								
FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	DATE	COUNTRY			TRANSLATION YES NO		
	AO	2-257652	10/18/1990	Japan					Х
	AP								,
	AQ								· -
	AR								
	AS								
	ΑT								
	AU								
	AV								
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)									
	AW								
	AX								
	AY						······································		
	AZ	□ Ad					Iditional References sheet(s) attached		
Examiner			····			Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									